

In re Application of: Yasunori INOUE et al.

Serial No.: 09/921,250

Group Art Unit: 1763

Filed: August 29, 1997

Examiner: G. Goudreau

For: FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE

LIQUID USED THEREIN

INFORMATION DISCLOSURE STATEMENT **CERTIFICATION PURSUANT TO 37 CFR 1.97(c)**

Commissioner for Patents Washington, D.C. 20231

April 23, 2001

Sir:

Submitted herewith is a copy of an Office Action dated February 23, 2001 which issued in related application serial no. 09/037,674. Also submitted herewith is a copy of each reference cited in that Office Action which has not yet been made of record in the present application.

This Information Disclosure Statement is being submitted after issuance of a first official action on the merits and expiration of the three month period following filing of the abovecaptioned application, but prior to issuance of either a final official action or a Notice of Allowance.

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. See 37 CFR 1.104(a) concerning the PTO duty to consider and use any such information. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

A check is attached hereto which covers the \$ 180.00 fee set forth in 37 CFR § 1.17(p).

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this Statement to our Deposit Account No. 01-2340. Two copies of this authorization are attached.

Respectfully submitted,

ARMSTRONG, WESTERMAN, HATTORI, McLELAND, NAUGHTON, LLP

Stephen G. Adrian Attorney for Applicants Reg. No.32,878

Atty. Docket No. 970813 1725 K Street, N.W., Suite 1000 Washington, DC 20006

Tel: (202) 659-2930 Fax: (202) 887-0357

SGA/arf

Enclosures: PTO-1449, 4 references and Office Action dated February 23, 2001

Check \$180.00 fee



In re the Application of: INOUE, et al.

Group Art Unit: 1763

Serial No.: 08/921,250

Examiner: GOUDREAU

Filed: August 29, 1997

P.T.O. Confirmation No.: 9314

For. FABRICATION METHOD OF SEMICONDUCTOR DEVICE AND ABRASIVE LIQUID USED THEREIN

INFORMATION DISCLOSURE STATEMENT AND STATEMENT PURSUANT TO 37 CFR 1.97(d)

Attn: Group Director

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

June 16, 2003

Sir:

This Information Disclosure Statement is submitted after the mailing of a final action, a Notice of Allowance, or an action that otherwise closes prosecution in the application, but on or before payment of the Issue Fee.

The undersigned hereby certifies that no item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, and, to the knowledge of the undersigned after making reasonable inquiry, no information contained in this statement was known to any individual designated in 37 CFR § 1.56(c) more than three months prior to the filing of this statement. The references were cited in an Office Action dated May 23, 2003 for U. S. Serial No. 09/320,271.

l

The above information is presented so that the Patent and Trademark Office can, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the documents cited in the attached Form PTO-1449 be made of record therein and appear on the first page of any patent to issue therefrom.

A check is attached hereto which covers the \$180.00 fee set forth in 37 CFR § 1.17(p).

The Commissioner is hereby authorized to charge any additional fee (or credit any overpayment) associated with this Statement to our Deposit Account No. 01-2340.

Respectfully submitted,

ARMSTRONG, WESTERMAN & HATTORI, LLP

Stephen G. Adrian
Attorney for Applicant
Reg. No. 32,878

SGA/arf Atty. Docket No. 970813 Suite 1000 1725 K Street, N.W. Washington, D.C. 20006 (202) 659-2930

23850

PATENT TRADEMARK OFFICE

Enclosures:

PTO-1449 and references (5)

\$180.00 fee